

L Number	Hits	Search Text	DB	Time stamp
1	278	huang-wen\$.in.	USPAT; US-PPGPUB; EPO; JPO; DERWENT; IBM TDB	2004/01/29 15:39
2	1	huang-wen\$.in. and stereolithography	USPAT; US-PPGPUB; EPO; JPO; DERWENT; IBM TDB	2004/01/29 15:40
3	39	stereolithography and fresnel	USPAT; US-PPGPUB; EPO; JPO; DERWENT; IBM TDB	2004/01/29 15:47
4	32	(stereolithography and fresnel) and (particle or particulate or powder)	USPAT; US-PPGPUB; EPO; JPO; DERWENT; IBM TDB	2004/01/29 15:42
8	1	((stereolithography and fresnel) and (particle or particulate or powder)) and (atomic adj particle adj beam)	USPAT; US-PPGPUB; EPO; JPO; DERWENT; IBM TDB	2004/01/29 15:46
5	23	((stereolithography and fresnel) and (particle or particulate or powder)) and uv	USPAT; US-PPGPUB; EPO; JPO; DERWENT; IBM TDB	2004/01/29 15:43
6	21	((stereolithography and fresnel) and (particle or particulate or powder)) and laser	USPAT; US-PPGPUB; EPO; JPO; DERWENT; IBM TDB	2004/01/29 15:45
7	1	((stereolithography and fresnel) and (particle or particulate or powder)) and (gamma adj ray)	USPAT; US-PPGPUB; EPO; JPO; DERWENT; IBM TDB	2004/01/29 15:46
9	883	lithography and fresnel	USPAT; US-PPGPUB; EPO; JPO; DERWENT; IBM TDB	2004/01/29 15:47
10	93	(lithography and fresnel) and (3d)	USPAT; US-PPGPUB; EPO; JPO; DERWENT; IBM TDB	2004/01/29 15:47
11	2	((lithography and fresnel) and (3d)) and (gamma adj ray)	USPAT; US-PPGPUB; EPO; JPO; DERWENT; IBM TDB	2004/01/29 15:49
12	0	((lithography and fresnel) and (3d)) and (atomic adj particle adj beam)	USPAT; US-PPGPUB; EPO; JPO; DERWENT; IBM TDB	2004/01/29 15:49